

**9<sup>th</sup> Central European Symposium on  
Plasma Chemistry (CESPC-9)**  
joint with  
**COST Action CA19110 Plasma Applications for  
Smart and Sustainable Agriculture (PIAgri)**

---

Vysoké Tatry, Slovakia  
September 4–9, 2022

# **BOOK OF ABSTRACTS**

including general information and program



Edited by Karol HENSEL, Richard CIMERMAN, Aleksandra LAVRIKOVA,  
Mário JANDA, and Zdenko MACHALA

**Title:** 9<sup>th</sup> Central European Symposium on Plasma Chemistry (CESPC-9) joint with  
COST Action CA19110 Plasma Applications for Smart and Sustainable Agriculture (PIAgri)  
**Subtitle:** Book of Abstracts (including general information and program)  
**Editors:** K. Hensel, R. Cimerman, A. Lavrikova, M. Janda, and Z. Machala  
**Publisher:** FMFI UK, Bratislava  
**Printing:** Neumahr s r.o., Bratislava, 2022  
**ISBN:** 978-80-8147-115-5  
**EAN:** 9788081471155

## Multi-hollow surface dielectric barrier discharge: Variations of gaseous products under conditions of various air flow rates and relative humidities

**R. Cimerman, K. Hensel**

Division of Environmental Physics, Faculty of Mathematics, Physics and Informatics,  
Comenius University, Bratislava, Slovakia  
e-mail: richard.cimerman@fmph.uniba.sk

Evaluation of gaseous products (reactive species) generated by the discharge is crucial for its employment in practical applications especially under ambient air conditions.

In this work, variations of the gaseous products of the multi-hollow surface dielectric barrier discharge (SDBD) in dry air were studied with respect to various discharge powers (1–5 W), air flow rates (0.25–2.4 L/min) and air relative humidities (0–80%). The discharge was generated by a perforated ceramic substrate in a configuration with the air-exposed electrode [1]. A unique geometry allowed the air to pass through holes (hollows) of the substrate inside which the discharge was formed enabling efficient production of several gaseous products. Out of them, production of ozone  $O_3$ , nitrous oxide  $N_2O$ , nitric oxide  $NO$ , nitrogen dioxide  $NO_2$ , dinitrogen pentoxide  $N_2O_5$  and nitric acid  $HNO_3$  were evaluated by means of FTIR spectroscopy and UV absorption in terms of concentration (ppm) and production yield (g/kWh).

The work demonstrated a critical impact of both air flow rate and air relative humidity on prevailing discharge mode (“ $O_3$  mode” vs. “ $NO_x$  mode”) and, thus, on production and composition of gaseous products. Whereas the air flow rate particularly determines the air residence time in a zone of generated discharge as well as gas heating, the air relative humidity influences the discharge from physical (processes of discharge formation, propagation, and its characteristics) and chemical aspects (production of H, OH,  $HO_2$  radicals). When the discharge operated in the “ $O_3$  mode”,  $O_3$ ,  $N_2O$ ,  $N_2O_5$  and  $HNO_3$  were observed among the gaseous products, while with the discharge transitioned to the “ $NO_x$  mode”,  $N_2O$  and  $HNO_3$  along with  $NO$  and  $NO_2$  were present. In dry air, the threshold of specific input energy (energy density) for a transition of the discharge from “ $O_3$  mode” to “ $NO_x$  mode” was approx. 1100 J/L, while with an increase of air relative humidity from 20 to 80%, it gradually decreased from approx. 600 to 450 J/L, respectively.

The work demonstrated that when the multi-hollow SDBD is generated under ambient air conditions, it generates various gaseous products in a wide range of concentrations that can be easily regulated by proper working conditions [2]. Therefore, the discharge may eventually find many possible applications, particularly in plasma pollution control and biomedicine.

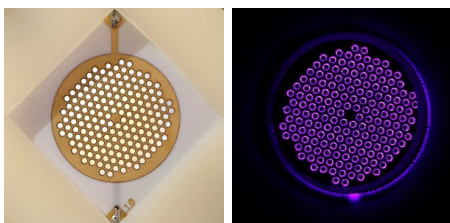


Fig. 1. The photographs of perforated ceramic substrate (left) and multi-hollow SDBD (right).

*This work was supported by grants of Slovak Research and Development Agency APVV-20-0566 and Slovak Grant Agency VEGA 1/0822/21.*

### References

- [1] R. Cimerman, E. Maťaš, M. Sárený, K. Hensel, *Phys. Plasmas*, submitted (2022).
- [2] R. Cimerman, K. Hensel, *Plasma Sources Sci. Technol.*, submitted (2022).